

Docket No. 03500.016072.1

Examiner: Long Pham

Date: October 13, 2004

MINEO SHIMOTSUSA, ET AL.

Application No.: 10/657,269

Filed: September 9, 2003 Group Art Unit: 2814

For: SEMICONDUCTOR DEVICE, METHOD FOR MANUFACTURING THE SAME, AND LIQUID

JET APPARATUS

**Mail Stop Amendment** 

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

No additional fee is required.

The fee has been calculated as shown below

CLAIMS AS AMENDED						
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	35	MINUS	34	= 1	x \$9 \$18	\$18.00
INDEP. CLAIMS	7	MINUS	7	= 0	x \$44 \$88	\$0.00
Fee for Multiple Dependent claims \$150/\$300					\$0.00	
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$18.00

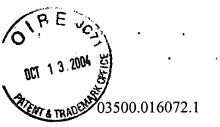
	Verified Statement claiming small entity status is	enclosed, if not filed previously.
X	A check in the amount of \$ 18.00	_ is enclosed.
	Charge \$ to Deposit Account No	. 06-1205. A duplicate copy of this sheet is enclosed.

X	Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.
	A check in the amount of \$ to cover the fee for a month extension is enclosed.
	A check in the amount of \$ to cover the Information Disclosure Statement fee is enclosed.
X	Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.
	Respectfully submitted,
	Daniel S. Glueck Attorney for Applicants Registration No.: 37,838

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza
New York, New York 10112-3800
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DSG/klm

Form #120

DC\_MAIN 181129v1



## **PATENT APPLICATION**

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Appli	cation of:	)	
MINEO SHIMOTSUSA, ET AL.			Examiner: Long Pham
Application No.: 10/657,269			Group Art Unit: 2814
Filed: September 9, 2003		)	
For:	SEMICONDUCTOR DEVICE, METHOD FOR MANUFACTURING THE SAME, AND LIQUID JET APPARATUS	· ) : )	October 13, 2004

## **Mail Stop Amendment**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

#### **AMENDMENT**

Sir:

# **Introductory Comments**

In response to the Official Action dated September 13, 2004, please amend

the above-referenced application as follows:

10/14/2004 HLE333 00000052 10657269 01 FC:1202 18.00 0P